

List of Reference Numerals

	101	substrate
	103	collector contact
5	105	base contact
	107	emitter contact
	109	BPSG
	111	contact via filled with tungsten
	113	contact via filled with tungsten
10	115	contact via filled with tungsten
	119	contact via filled with tungsten
	121	contact via filled with tungsten
	123	contact via filled with tungsten
	117	first structured metal plane
15	125	second structured metal plane
	127	gate polystack
	201	substrate
	203	substrate surface
	205	first terminal
20	207	first terminal surface
	209	stack
	211	second terminal
	213	second terminal surface
	215	first insulating layer
25	217	contact via
	219	conductive material
	221	second insulating layer
	223	etching mask
	225	area for a first contact terminal
30	227	area for a second contact terminal
	229	first recess
	231	second recess
	233	conductive material
	235	conductive material
35	237	first contact terminal
	239	second contact terminal
	301	gate terminal
	303	third insulating layer

305 further contact via
307 further contact via
309 conductive material
311 conductive material
5 313 fourth insulating layer
315 third recess
317 fourth recess
319 conductive material
321 conductive material
10 401 insulating-layer surface
403 first conductive material
405 second conductive material
407 third conductive material

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